

STATES PATENT AND TRADEMARK OFFICE

rn re Patent Application of Yoshiki Hirano et al. Application No.: 10/658,392 Filed: September 10, 2003 For: ION ATTACHMENT MASS SPECTROMETRY METHOD	Group Art Unit: 2881 Examiner: KIET TUAN NGUYEN Confirmation No.: 2266))
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AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 21, 2004, please amend the above-identified patent application as follows: